Docket No.: 0216-0516PUS1

(Patent)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Toshihiko OHASHI et al.

Application No.:

10/541,776

Confirmation No.: 1474

Filed:

July 08, 2005

Art Unit:

1794

For:

SILICA-CONTAINING LAMINATED

Examiner:

V. CHANG

STRUCTURE, AND COATING

COMPOSITION FOR USE IN FORMING A

POROUS SILICA LAYER

## **AMENDMENT UNDER 37 C.F.R. § 1.116**

DO NOT ENTER: /V.C./

MS AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **INTRODUCTORY COMMENTS**

In reply to the Office Action dated July 30, 2010, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims begin on page 2.

Remarks begin on page 8.

**Attachments: Exhibits 1-3**